

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Confirm. No.: 1791

NAKAYAMA ET AL.

Atty. Ref.: 925-342

Serial No. 10/581,247

TC/A.U.: 2822

Filed: May 31, 2006

Examiner: Green, T.D.

For: SILICON CARBIDE SEMICONDUCTOR DEVICE AND
MANUFACTURING METHOD THEREFOR

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January 25, 2010

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

Responsive to the Official Action dated October 23, 2009, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2.

Remarks/Arguments begin on page 3.